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Application Number		10591718
Filing Date		2006-09-05
First Named Inventor	Keita	Ishiduka
Art Unit		1795
Examiner Name	Conni	ie P. Johnson
Attorney Docket Numb	er	1608-7 PCT/US

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 Examiner Name
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/C.J./	2	TAYLOR J C ET AL: "Implications of immersion lithography on 193nm photoresists" PROCEEDING OF THE SPIE, vol. 5376, 23 February 2004(2004-02-23), pages 34-43, XP002509684 Bellingham					
HINSBERG W ET AL: "Liquid immersion lithography - Evaluation of resist issues" PROCEEDINGS OF THE SPIE, SPIE, BELLINGHAM, VA; US, vol.5376, 1 February 2004 (2004-02-01), pages 21-33, XP002477117							
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